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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/566,355	01/30/2006	Yutaka Yamagata	126818	2525
25944	7590	05/12/2009	EXAMINER	
OLIFF & BERRIDGE, PLC			DAVIS, OCTAVIA L	
P.O. BOX 320850				
ALEXANDRIA, VA 22320-4850			ART UNIT	PAPER NUMBER
			2855	
			MAIL DATE	DELIVERY MODE
			05/12/2009	PAPER

**Please find below and/or attached an Office communication concerning this application or proceeding.**

The time period for reply, if any, is set in the attached communication.

<b>Office Action Summary</b>	<b>Application No.</b>	<b>Applicant(s)</b>	
	10/566,355	YAMAGATA ET AL.	
	<b>Examiner</b>	<b>Art Unit</b>	
	OCTAVIA DAVIS	2855	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

#### Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

#### Status

1) Responsive to communication(s) filed on 21 January 2009.

2a) This action is **FINAL**.                    2b) This action is non-final.

3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

#### Disposition of Claims

4) Claim(s) 1-15 is/are pending in the application.

4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.

5) Claim(s) \_\_\_\_\_ is/are allowed.

6) Claim(s) 1-15 is/are rejected.

7) Claim(s) \_\_\_\_\_ is/are objected to.

8) Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

#### Application Papers

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on \_\_\_\_\_ is/are: a) accepted or b) objected to by the Examiner.

Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).

11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

#### Priority under 35 U.S.C. § 119

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).

a) All    b) Some \* c) None of:

1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

#### Attachment(s)

1) Notice of References Cited (PTO-892)

2) Notice of Draftsperson's Patent Drawing Review (PTO-948)

3) Information Disclosure Statement(s) (PTO/SB/08)  
Paper No(s)/Mail Date \_\_\_\_\_.

4) Interview Summary (PTO-413)  
Paper No(s)/Mail Date. \_\_\_\_\_.

5) Notice of Informal Patent Application

6) Other: \_\_\_\_\_.

**DETAILED ACTION**

Acknowledgment is made of applicant's amendment filed 1/21/09.

***Claim Rejections - 35 USC § 103***

1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

2. Claims 1, 2 and 4 - 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Bashir et al (6,935,165) in view of Valadier (4,478,093).

Regarding claim 1, Bashir et al disclose a microscale sensor element and related device and method of use comprising a minute mechanical structure body 106 having a functional membrane 110 formed at least on one part of its surface, supporting means 102 for supporting the minute mechanical structure body 106 and detection means 108 for detecting the change of a mechanical property of the minute mechanical structure body (See Col. 24, lines 44 – 54) but does not disclose that the body has a supporting portion and a pair of arms connected via elastic hinges to the supporting portion, a functional membrane connected to the arms, a detection means including a force sensor that is connected to one of the arms and an actuator that provides tension to the functional membrane and that is connected to the other arm. However, Valadier disclose a dynamometer of a cantilever type comprising a supporting portion 94, a pair of arms 114, 116, 118, 120 connected via elastic hinges 106, 108, 110, 112 to the supporting portion, a functional

membrane 10 connected to the arms via beam 10 which contacts the sensors, a force sensor(s) 34, 36, 38, 40 connected to an arm and a tension applier (See Col. 8, lines 23 - 29) connected to an arm (See Col. 1, lines 28 – 32, Col. 3, lines 58 - 61, Col. 4, lines 57 – 61 and Col. 8, lines 40 - 44).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Bashir et al according to the teachings of Valadier for the purpose of, advantageously providing a bending dynamometer of which the sensing means utilizes a resistant wire wound on the testing member to permit the production of a varied range of industrial dynamometers (See Valadier, Col. 8, lines 47 – 50).

Regarding claim 2, in Bashir et al, the minute structure body 106 is provided on an upper surface of the supporting means 102 and the functional membrane 110 is capable of being deposited in thin layers on each structure body (See Col. 18, lines 5 – 14).

Regarding claim 4, in Bashir et al, the functional membrane 110 is made of a polymeric material (See Col. 24, lines 51 – 54).

Regarding claims 5 and 6, in Bashir et al, the functional membrane 110 is formed directly on a surface of the minute structure body 106 by deposition (See Col. 20, lines 40 – 42, Col. 21, lines 66 – 67 and Col. 22, lines 1 – 6).

“[E]ven though product-by-process claims are limited by and defined by the process, determination of patentability is based on the product itself. The patentability of a product does not depend on its method of production. If the product in the product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product was made by a different process.” In re Thorpe, 777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985).

Since the product in claims 5 and 6 is a deposited membrane, and such a deposited membrane is disclosed by Bashir et al, the claim is unpatentable even though made by a different process. See MPEP 2113.

Regarding claim 7, in Bashir et al, the detection means 108 comprises a zone which will not be displaced or displaced negligibly even when a mechanical property of the functional membrane is changed, and the minute structure body has its one end immersed into a test solution such that said zone is close to the surface of the test solution.

Regarding claims 8, 9 and 13 - 15, in Bashir et al, the detection means detects a deformation due to the stress on the cantilever (See Col. 22, lines 34 – 52 and Col. 24, lines 44 - 54) and the functional membrane 110 includes an environmentally sensitive configuration which changes in accordance with the presence and absence of an environmental parameter, wherein the change or swelling of the functional membrane results in the actuation of the structure body 106 (See Col. 24, lines 19 – 24).

Regarding claims 10 – 12, in Bashir et al, the minute mechanical structure body 106 comprises a minute cantilever having the functional membrane or layer 110 formed thereon and the detection means 108 is a sensor capable of detecting the bending deformation of the minute cantilever of the minute mechanical structure body (See Col. 24, lines 44 – 54).

3. Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over Bashir et al and Valadier, as applied to claims 1, 2 and 4 – 15 above, and further in view of Lang et al “An artificial nose based on a micromechanical cantilever array”.

Regarding claim 3, Bashir et al and Valadier disclose all of the limitations of these claims except that a plurality of minute structure bodies are provided and each structure comprises a different functional membrane. However, in Lange et al, a microfabricated array of silicon

cantilevers is provided wherein each is coated with a specific and different sensor layer which transduces a chemical reaction into a mechanical response, the specific sensor layer including metals, monolayers or polymers (See the “Introduction” section on Page 1).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Bashir et al and Valadier according to the teachings of Lang et al for the purpose of, advantageously providing a novel chemical sensor based on a micromechanical array of silicon cantilevers having different cantilever coatings to allow the operation of the array device as a new form of chemical nose (See the abstract of Lang et al, lines 4 and 5).

### ***Response to Arguments***

4. Applicant's arguments filed 1/21/09 have been fully considered but they are not persuasive. In response to applicant's arguments on Pg. 2, lines 14 - 21 and Pg. 3, lines 4 - 6, that the references do not disclose a functional membrane and an actuator providing tension to the functional membrane that is connected to the arms, it is the examiner's position that in Bashir et al, the body 106 includes a functional membrane polymeric layer 110 formed thereon (See Fig. 1) and in Valadier, the beam 10 is a thin or lightly layered beam (See Col. 2, lines 16 – 23 and Col. 3, lines 50 – 52) and a tension applying means (not shown) applies a tension to the beam via a plate support 124 that is connected to the arm members 114, 116, 118, 120 (See Col. 6, lines 59 - 68 and Col. 7, lines 1 - 2), thus the references still stand.

5. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the

mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

***Conclusion***

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Octavia Davis whose telephone number is 571-272-2176. The examiner can normally be reached on Mon through Thurs from 9 to 5. The examiner can also be reached on alternate Fridays.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Lisa Caputo, can be reached on 571-272-2388. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

/O. D./  
Examiner, Art Unit 2855  
5/5/09

/Lisa M. Caputo/

Supervisory Patent Examiner, Art Unit 2855

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